

Notice of References Cited	Application/Control No. 10/811,222		Applicant(s)/Patent Under Reexamination CHAO ET AL.	
	Examiner TIPHANY B. DICKERSON		Art Unit 3623	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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*	B	US-2005/0216317	09-2005	Medellin et al.	705/006
*	C	US-7,483,761	01-2009	Wang et al.	700/100
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*	E	US-6,763,277	07-2004	Allen et al.	700/100
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*	G	US-7,522,969	04-2009	Duffin et al.	700/112
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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)			
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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